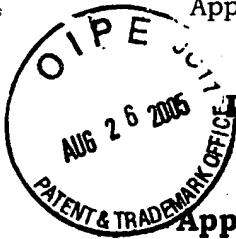


1FW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Appl. No. : 10/685,588**  
**Applicants : Chia-Lin Hsu et al.**  
**Filed : October 16, 2003**  
**Title : Method for Preventing Edge Peeling Defect**  
**TC/A.U. : 2891**  
**Examiner : EVERHART, CARIDAD**  
**Docket No. : 025796-00009**  
**Response Dte : August 26, 2005**

Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

This paper is in response to the Official Action dated June 27, 2005. Applicants respectfully request that Examiner reconsiders the application according to the following remarks.

Please amend the above-identified application as follows:

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.